



**REPLY UNDER 37 C.F.R. § 1.116  
EXPEDITED PROCEDURE  
TECHNOLOGY CENTER ART UNIT 4649**

Attorney Docket No.: 040258/0279274  
Client Reference: EL01001CDC

**IN THE UNITED STATES PATENT AND TRADEMARK OFFICE**

In re Application of:  
**HONGO *et al.***

Confirmation No. 4649

Application No.: **09/815,305**

Filed: March 23, 2001

ART UNIT: 1763

Title: PLASMA PROCESSING APPARATUS  
HAVING AN EVACUATING ARRANGEMENT TO  
EVACUATE GAS FROM A GAS-INTRODUCING  
PART OF A PROCESS CHAMBER  
Examiner: ALEJANDRO, M. L.

\* \* \* \*

January 7, 2005

**AMENDMENT AFTER FINAL REJECTION UNDER 37 C.F.R. § 1.116  
WITH REQUEST FOR CONTINUED EXAMINATION**

**Mail Stop AF**  
Commissioner for Patents  
P.O. Box 1450  
Alexandria, VA 22313-1450

Sir:

Responsive to the Office Action dated August 10, 2004, a response to which is due January 10, 2005 with the payment of a two-month extension fee, please amend the above-identified application as follows.

01/10/2005 ZJU HAR1 00000077 033975 09815305  
02 FC:1252 450.00 DA